



NEW ATTORNEY DOCKET NO.: 052640-5031-01

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re Application of:	)	
	)	Confirmation No. 5216
Namwoong PAIK et al.	)	
	)	Group Art Unit: 1753
Application No.: 10/695,485	)	
	)	Examiner: Unassigned
Filed: October 29, 2003	)	
	)	
For: METHOD OF FORMING NON-OXIDE	)	
THIN FILMS USING NEGATIVE	)	
SPUTTER ION BEAM SOURCE	)	

Commissioner for Patents  
U.S. Patent and Trademark Office  
2011 South Clark Place  
**Customer Window, MS Non-Fee Amendment**  
Crystal Plaza Two, Lobby, Room 1B03  
Arlington, VA 22202

Sir:

**SUPPLEMENTAL PRELIMINARY AMENDMENT**

Prior to the examination on the merits of the above-identified application, please amend  
the above-identified application as follows: